

Notice of References Cited	Application/Control No. 10/577,441		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner VAN N. CHOW		Art Unit 2627	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0026179	02-2003	Nagahara et al.	369/44.37
*	B	US-7,215,609	05-2007	Shimano et al.	369/44.37
*	C	US-2004/0105374	06-2004	Ogasawara et al.	369/112.02
	D	US-			
*	E	US-2004/0114495	06-2004	Kim et al.	369/112.24
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	I					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.